

NaDiaProbes[®] — All-Diamond AFM Probes

Leveraging diamond's wear resistance, chemical inertness and low friction properties



Advanced Diamond Technologies' (ADT) NaDiaProbes are changing the field of AFM probes. Made entirely of diamond — both the tip and cantilever—in a monolithic process, NaDiaProbes leverage the beneficial attributes of diamond in standard geometries for use in commercial atomic force microscopes (AFM). Diamond has long been recognized as the optimal material for scanning probe microscope applications, but until now the available technology—diamond-coated cantilevers or mounted pieces of diamond—has been unable to meet industry requirements for sharpness, reproducibility and affordability.

Problems associated with silicon (Si) and silicon nitride (SiN) probes such as wear resistance and reactivity are overcome with NaDiaProbes due to diamond's intrinsic hardness and inertness. With imaging results frequently better than 20 nm, NaDiaProbes outperform diamond-coated silicon probes in image resolution. NaDiaProbes exhibit imaging performance comparable to standard SiN probes but with over 100x less wear rates.



Modes and Applications

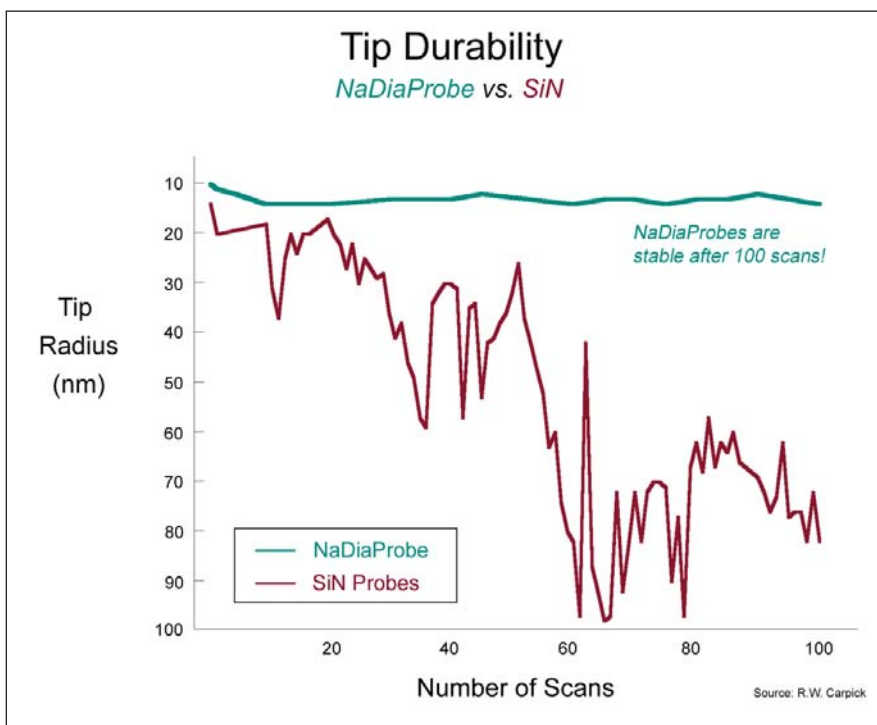
NaDiaProbes have a chip geometry that allows use in most standard AFM tools. All NaDiaProbes have an aluminum reflective coating. NaDiaProbes can be used for the following AFM scanning modes:

- Conductive Microscopy
- Dynamic (Tapping) Mode
- Contact Mode

NaDiaProbes are excellent for the following applications:

- Scanning Spreading Resistance Microscopy (SSRM)
- Oxidation Nanolithography
- Wear Resistance on Hard Substrate
- Long Tip Lifetime (Quality Control)

NaDiaProbes are made using ADT's multicrystalline diamond, UNCD[®], which has many of the desirable characteristics of diamond such as hardness, modulus and fracture toughness. Because of UNCD's hardness, the tips resist damage which enhances resolution and increases tip lifetimes. UNCD also has diamond's exceptional surface properties of low friction and stiction for superior all-around imaging performance particularly on soft materials.



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NaDiaProbes® — All-Diamond AFM Probes



Conductive Probes

Conductive NaDiaProbes are all diamond probes with the cantilever and the probe tip made of electrically conductive UNCD® with a resistivity less than 1 ohm-cm. In addition to being electrically conductive, NaDiaProbes display superior wear properties and long lifetimes. Therefore, users who are frustrated with the delamination of conductive metal coatings will be pleased to know NaDiaProbes are conductive inside and out.

No coating — all conductive diamond.

SSRM ♦ Oxidation Nanolithography ♦ E-Chem AFM ♦ Piezo-Force Microscopy

Dynamic Mode

Dynamic (tapping) mode NaDiaProbes are designed for the most common use of AFM probes — tapping a surface. Due to diamond's superior wear properties, these probes are designed for imaging hard surfaces, any application where long tip life is desirable (quality control processes) and applications where silicon tips may break easily. Therefore NaDiaProbes are also excellent for new AFM users.

Wear Resistance on Hard Surfaces ♦ Nanomanufacturing



Contact Mode

Contact mode NaDiaProbes are designed for imaging hard surfaces for many scans. Extremely wear resistant, NaDiaProbes last orders of magnitude longer than silicon nitride (SiN) or silicon (Si) probes. Extremely durable, NaDiaProbes are also perfect for new users or applications where a Si tip may break easily.

Scanning Hard Surfaces ♦ Quality Control ♦ New Users ♦ Long Tip Lifetimes

For a complete list of NaDiaProbe specifications and ordering information, please visit store.nanoscience.com.

UNCD Properties and NaDiaProbe Advantages

UNCD Properties	NaDiaProbe Advantages
Extreme hardness and strength	Robust probes with excellent imaging resolution
Extremely high modulus and low dissipation	High frequency for dynamic imaging
Extremely wear resistant	Consistent imaging resolution when scanning hard surfaces Holds dimensional tolerances for metrology and quality control applications
Low film stress	Cantilevers, regardless of length, maintain integrity and do not bend
Chemically inert and stable	Resists build-up of debris when imaging soft materials Resists fouling of biomaterials

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This product is protected by one or more of the following
U.S. and foreign patents: 5,989,511; 6,592,839; 7,128,889;
5,849,079; 5,772,760. Additional patents pending.

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ND-CTC SERIES: CONDUCTIVE

TIP
Shape: (111) Pyramid
Height: 5.66 μm
Radius: 15-30 nm (nominal, guaranteed < 50 nm)
Material: Conductive UNCD® (diamond)

CANTILEVER
Tip Setback: 9 μm
Coating: 60 nm reflective aluminum coating
Curvature: Typically less than 3 degrees
Chip: Standard size Pyrex (3.6 x 1.5 x 0.5 mm)

SKU	CHIP IMAGE	CANTILEVER	FORCE CONSTANT (N/M)		FREQUENCY (KHZ)		LENGTH (μM)	WIDTH (μM)	THICKNESS (μM)	MSRP (PACK OF 2)
			NOMINAL	RANGE	NOMINAL	RANGE	(± 5)	(± 2)	(± 0.05)	
ND-CTCR1-2		Short	0.35	0.25-0.45	35	20-50	225	30	1	\$249
		Medium	0.17	0.10-0.25	17	10-25	325	40	1	
		Long	0.04	0.02-0.05	12	6-20	425	20	1	
ND-CTCR2-2		Short	0.23	0.15-0.30	40	20-60	225	20	1	\$249
		Medium	0.08	0.05-0.10	12	6-20	425	40	1	
		Long	0.05	0.03-0.07	8	4-16	500	40	1	
ND-CTCT1-2		Short	1.28	1.00-1.50	48	25-70	200	25	1	\$249
		Long	0.46	0.30-0.60	24	12-40	300	41	1	
ND-CTCT2-2		Short	0.71	0.50-0.95	50	25-75	200	17	1	\$249
		Long	0.04	0.02-0.05	23	12-45	300	23	1	



ND-DYI SERIES: DYNAMIC MODE

TIP
Shape: (111) Pyramid
Height: 5.66 μm
Radius: 15-30 nm (nominal, guaranteed < 50 nm)
Material: UNCD® (diamond)

CANTILEVER
Tip Setback: 9 μm
Coating: 60 nm reflective aluminum coating
Curvature: Typically less than 3 degrees
Chip: Standard size Pyrex (3.6 x 1.5 x 0.5 mm)

SKU	CANTILEVER	FORCE CONSTANT (N/M)		FREQUENCY (KHZ)		LENGTH (μM)	WIDTH (μM)	THICKNESS (μM)	MSRP (PACK OF 4)
		NOMINAL	RANGE	NOMINAL	RANGE	(± 5)	(± 2)	(± 0.05)	
ND-DYIRS-4	1 Cantilever per chip	34	25-40	310	200-400	120	33	2.5	\$249
ND-DYIRL-4	1 Cantilever per chip	28	20-35	240	150-350	130	33	2.5	\$249



ND-CTI SERIES: CONTACT MODE

Contact Mode probes have the same tip and cantilever specifications as conductive probes, ND-CTC Series (above).

SKU	CHIP IMAGE	CANTILEVER	FORCE CONSTANT (N/M)		FREQUENCY (KHZ)		LENGTH (μM)	WIDTH (μM)	THICKNESS (μM)	MSRP (PACK OF 4)
			NOMINAL	RANGE	NOMINAL	RANGE	(± 5)	(± 2)	(± 0.05)	
ND-CTIR1-4		Short	0.35	0.25-0.45	35	20-50	225	30	1	\$249
		Medium	0.17	0.10-0.25	17	10-25	325	40	1	
		Long	0.04	0.02-0.05	12	6-20	425	20	1	
ND-CTIR2-4		Short	0.23	0.15-0.30	40	20-60	225	20	1	\$249
		Medium	0.08	0.05-0.10	12	6-20	425	40	1	
		Long	0.05	0.03-0.07	8	4-16	500	40	1	
ND-CTIT1-4		Short	1.28	1.00-1.50	48	25-70	200	25	1	\$249
		Long	0.46	0.30-0.60	24	12-40	300	41	1	
ND-CTIT2-4		Short	0.71	0.50-0.95	50	25-75	200	17	1	\$249
		Long	0.04	0.02-0.05	23	12-45	300	23	1	